

Search Notes

Application/Control No.

10/725,062

Examiner

Rodney E. Fuller

Applicant(s)/Patent under
Reexamination

SHIMA, SHINICHI

Art Unit

2851

SEARCHED

Class	Subclass	Date	Examiner
355	52 53 67 77	3/29/2005	REF

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East: expsoure + mask + wafer + optical modulation + adjusting unit + matching + relation + reference plate + reference mark	3/29/2005	REF